

  <b>FORM PTO-1449</b> <b>INFORMATION DISCLOSURE CITATION</b>		Atty Docket 26102	Serial No. 10/827,330
		Applicant NAKAMURA	
		Filing Date April 20, 2004	Group Art Unit Not Yet Assigned

  

U.S. PATENT DOCUMENTS							
Examiner Initial		Document Number	Issue Date	Name	Class	Sub-Class	Filing Date
	AA						
	AB						
	AC						
	AD						
	AE						
	AF						

  

FOREIGN PATENT DOCUMENTS							
		Document Number	Date	Country	Class	Sub-Class	Trans-lation
MH	AG	2000-091078	31 Mar 2000	JP			Abstract
MH	AH	2001-332390	30 Nov 2001	JP			Abstract
MH	AI	2000-243569	08 Sep 2000	JP			Abstract
MH	AJ	2000-243567	08 Sep 2000	JP			Abstract
	AK						

  

OTHER (Including Author, Title, Date, Pertinent Pages, etc.)			
MH	AL		Abstract: 27a-A-6, Oyamada, T. et al., "OLED characteristics using low work function metals and the application for thick-film OLEDs", <u>Proceeding Paper of the 50<sup>th</sup> applied physics associated conference in Japan, pp.1402, (March 2003).</u>
	AM		
	AN		

  

Examiner /Matthew Hodges/	Date Considered 07/24/2006
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